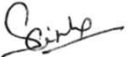


**BIRLA INSTITUTE OF TECHNOLOGY, MESRA, RANCHI, INDIA****END SEMESTER EXAMINATION SCHEDULE MO/2025****PROGRAMME NAME: BTECH****SEMESTER: 7th****CENTRE NAME: MESRA / DEOGHAR / JAIPUR / PATNA****DATE: 07/11/2025**

DATE/DAY	CSE-VII / AIME-VII / EEE-VII / ECE-VII / BT-VII	ME-VII / PE-VII / CE-VII / CHEM. ENGG.
	[TIME: 10:00 AM TO 01:00 PM]	
19/11/2025 WEDNESDAY	IT331 IMAGE PROCESSING [P] / CS435 FRONTEND DESIGN [MDJ] / CS437 DEEP LEARNING [MJ]	MT204 CONSTITUTION OF INDIA [MDP]
	AI401 REINFORCEMENT LEARNING [MP]	MT204 CONSTITUTION OF INDIA [M]
	EE437 INDUSTRIAL DRIVES AND CONTROL [M] / EE439 APPLIED CONTROL THEORY [M]	MT204 CONSTITUTION OF INDIA [MP]
	EE441 COMPUTER-AIDED POWER SYSTEM ANALYSIS [DP]	MT204 CONSTITUTION OF INDIA [M]
	EC401 MICROWAVE THEORY AND TECHNIQUES [MDJP]	XXXXXX
20/11/2025 THURSDAY	MT204 CONSTITUTION OF INDIA [M]	CS431 COMPUTER GRAPHICS [DP] / IT347 CLOUD COMPUTING [MJ]
	ME401 REFRIGERATION & AIR CONDITIONING [MDP]	AI425 COMPUTER VISION [M] / IT347 CLOUD COMPUTING [M]
	CE401 COMPUTER INTEGRATED MANUFACTURING & CYBER-PHYSICAL SYSTEMS [M]	EE573 EMBEDDED SYSTEMS AND APPLICATIONS [M] / EE585 HYBRID ELECTRIC VEHICLE [MJ]
	CE420 AIR POLLUTION AND CONTROL [P] / CE423 HARBOUR & AIRPORT ENGINEERING [M]	EE605R1 MICRO-GRID OPERATION AND CONTROL [DP]
	CE437 TRANSPORTATION PLANNING [M]	EC417 SATELLITE COMMUNICATION [MDJP] / EC421 REAL TIME EMBEDDED SYSTEM [M]
21/11/2025 FRIDAY	CL407 PROCESS MODELING, SIMULATION & OPTIMIZATION [M]	BE402 BIOREACTOR AND BIOPROCESS DESIGN [M]
	XXXXXX	CS439 PARALLEL COMPUTING [D]
	ME409 INDUSTRIAL MANAGEMENT [MDP] / ME479 ADVANCED HEAT TRANSFER [M]	IT349 CRYPTOGRAPHY & NETWORK SECURITY [MP]
	PE406 NON-CONVENTIONAL MACHINING PROCESSES [M]	XXXXXX
	PE407 ADVANCED MANUFACTURING PROCESSES [M]	EC409 WIRELESS COMMUNICATION [MDJP] / EC415 NEURAL NETWORK AND FUZZY SYSTEM [M]
24/11/2025 MONDAY	CE411 ADVANCE STRUCTURAL ANALYSIS [M] / CE436 ADVANCE STEEL STRUCTURES DESIGN [M]	BE407 NANOBIOTECHNOLOGY [M]
	CL433 POLYMER COMPOSITE [M] / CL435 ELASTOMER TECHNOLOGY [M]	XXXXXX
	CL441 PAINTS AND SURFACE COATING TECHNOLOGY [M]	IT445 INTERNET OF THINGS [D]
	XXXXXX	IT445 INTERNET OF THINGS [P]
	PE411 SUPPLY CHAIN MANAGEMENT [M]	EE507 ADVANCED POWER ELECTRONICS [J]
25/11/2025 TUESDAY	CE419 ADVANCED GEOTECHNICAL ENGINEERING [P]	EC425 LOW POWER VLSI CIRCUIT [P] / EC427 ASIC DESIGN [MDJ]
	CL421 FIBRE SCIENCE & TECHNOLOGY [M] / CL425 PLASTIC PACKAGING TECHNOLOGY [M]	EC431 DIGITAL IMAGE AND VIDEO PROCESSING [M] / EC433 WIRELESS SENSORS & NETWORKS [D]
	CL429 CHEMICAL PROCESS INTENSIFICATION [M]	BE313 METABOLIC ENGINEERING [M] / BE412 PROCESS BIOTECHNOLOGY [M]
	XXXXXX	
[OPEN ELECTIVE]		
26/11/2025 WEDNESDAY	GI501 PRINCIPLES OF REMOTE SENSING [M] / HS403 FRENCH-II [P]	CS461 FUNDAMENTAL OF MACHINE LEARNING [P]
	PE417 PRODUCTION MANAGEMENT [M]	
	GI501 PRINCIPLES OF REMOTE SENSING [M] / HS403 FRENCH-II [P]	CS461 FUNDAMENTAL OF MACHINE LEARNING [P] / GI501 PRINCIPLES OF REMOTE SENSING [M]
	CS461 FUNDAMENTAL OF MACHINE LEARNING [P] / PE417 PRODUCTION MANAGEMENT [M]	PE417 PRODUCTION MANAGEMENT [M]
	CS461 FUNDAMENTAL OF MACHINE LEARNING [MP] / PE417 PRODUCTION MANAGEMENT [M]	PE417 PRODUCTION MANAGEMENT [M]
26/11/2025 WEDNESDAY	SR511 FUNDAMENTALS OF FUELS & COMBUSTION [M]	XXXXXX
	PE417 PRODUCTION MANAGEMENT [M]	XXXXXX
	XXXXXX	XXXXXX
	XXXXXX	XXXXXX
	XXXXXX	XXXXXX

INSTRUCTIONS:

- CANDIDATES ARE ADVISED TO READ THE "INSTRUCTIONS TO EXAMINEES" AVAILABLE ON EXAMINATION TAB OF THE INSTITUTE WEBSITE.
- CANDIDATES MUST BRING HALL TICKET AND IDENTITY CARD WITHOUT WHICH THEY WILL NOT BE PERMITTED TO ENTER THE EXAMINATION HALL.
- ELECTRONIC GADGETS (EXCEPT CALCULATOR), BOOKS OR OTHER WRITTEN MATERIALS ARE NOT ALLOWED INSIDE THE EXAMINATION HALL.
- CANDIDATES ARE ADVISED TO REACH THE EXAMINATION HALL 20 MINUTES BEFORE THE START OF EXAMINATION.
- CANDIDATES ARE ADVISED TO SEE THE "SEATING PLAN" ON EXAMINATION TAB OF THE INSTITUTE WEBSITE ONE DAY BEFORE THE COMMENCEMENT OF EXAMINATION.
- TEMPORARY ABSENCE DURING THE FIRST TWO EXAMINATION HOURS IS NOT ALLOWED.


PREPARED BY
 (SANTOSH KR. SINHA)


AR (EXAMINATION)


CONTROLLER OF EXAMINATIONS